

## Claims

[c1] 1.A method for performing an electromigration check for conductors with alternating current flow adjacent to conductors with direct current flow in an integrated circuit comprising:

determining resistances  $R_{\text{WIRE}}$  and a capacitance matrix  $C$  for the integrated circuit;

converting the capacitance matrix  $C$  into a thermal conductance matrix  $G$ ;

determining temperature differences  $\Delta T_{\text{ni}}$  between conductors from thermal conductances  $G_{\text{thi}}$  of the thermal conductance matrix  $G$ ;

approximating power flow  $P_{\text{n}}$  into conductors with direct current flow due to adjacent conductors with alternating current flow in the integrated circuit from the temperature differences  $\Delta T_{\text{ni}}$  between conductors and the thermal conductances  $G_{\text{thi}}$ ;

determining a power limit as a function of the maximum temperature difference  $\Delta T_{\text{MAX}}$  that ensures reliability of the integrated circuit; and

performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit.

- [c2] 2.The method of claim 1, wherein the thermal conductance matrix  $G$  is determined from the product of the capacitance matrix  $C$  and a scalar factor  $F$  and the scalar factor is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .
- [c3] 3.The method of claim 1, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$
- [c4] 4.The method of claim 1, wherein the  $I_{RMS}$  value is determined by the expression:  
 $C_{load} * V_{dd} * frequency * Switching\ factor.$
- [c5] 5.The method of claim 1, wherein the thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{ni}$  as outputs of the circuit simulator.
- [c6] 6.The method of claim 1, wherein the capacitance matrix  $C$  and resistances  $R_{WIRE}$  are determined by using simulation and analysis tools that at least include capacitance/resistance extraction capabilities.
- [c7] 7.A method for performing an electromigration check for conductors with alternating current flow adjacent to con-

ductors with direct current flow comprising:

determining resistances  $R_{\text{WIRE}}$  and capacitances  $C_{\text{ni}}$  for conductors with alternating current flow and conductors with direct current flow;

converting the capacitances  $C_{\text{ni}}$  into thermal conductances  $G_{\text{thi}}$ ;

determining temperature differences  $\Delta T_{\text{ni}}$  between conductors from the thermal conductances  $G_{\text{thi}}$ ;

approximating power flow  $P_{\text{n}}$  into conductors with direct current flow due to adjacent conductors with alternating current flow from the temperature differences  $\Delta T_{\text{ni}}$  between conductors and thermal conductances  $G_{\text{thi}}$ ;

determining a power limit as a function of a maximum temperature difference  $\Delta T_{\text{MAX}}$  for the conductors that ensures reliability of the conductor; and

performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit.

- [c8] 8. The method of claim 7, wherein the thermal conductances  $G_{\text{thi}}$  are determined from the product of the capacitances  $C_{\text{ni}}$  and a factor F and the scalar factor F is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

- [c9] 9.The method of claim 7, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{\text{ntot}}$  and the maximum temperature difference  $\Delta T_{\text{MAX}}$
- [c10] 10.The method of claim 7, wherein the  $I_{\text{RMS}}$  value is determined by the expression:  
 $C_{\text{load}} * V_{\text{dd}} * \text{frequency} * \text{Switching factor}.$
- [c11] 11.The method of claim 7, wherein the thermal conductances  $G_{\text{thi}}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{\text{ni}}$  as outputs of the circuit simulator.
- [c12] 12.The method of claim 7, wherein the capacitances  $C_{\text{ni}}$  and resistances  $R_{\text{WIRE}}$  are determined by using simulation and analysis tools that at least include capacitance/resistance extraction capabilities.
- [c13] 13.A method for performing a check of local heating in a device comprising:  
determining resistances  $R_{\text{WIRE}}$  and at least one of capacitances  $C_{\text{ni}}$  and a capacitance matrix  $C$  for the device;  
determining thermal conductances  $G_{\text{thi}}$  from the at least one of capacitances  $C_{\text{ni}}$  and a capacitance matrix  $C$ ;

setting a maximum temperature difference  $\Delta T_{MAX}$  in accordance with electromigration requirements; determining a power limit  $F \cdot C_{ntot} \cdot \Delta T_{MAX}$  as a function of the maximum temperature difference  $\Delta T_{MAX}$ ; checking each interconnect conductor with an alternating current flow to determine if power generated  $I_{RMS}^2 \cdot R_{WIRE}$  is less than the power limit  $F \cdot C_{ntot} \cdot \Delta T_{MAX}$ ; indicating no local heating problem with an interconnect conductor when power generated  $I_{RMS}^2 \cdot R_{WIRE}$  is less than the power limit  $F \cdot C_{ntot} \cdot \Delta T_{MAX}$ ; indicating a local heating problem exist with current interconnect conductor when the power generated  $I_{RMS}^2 \cdot R_{WIRE}$  is equal to or greater than power limit  $F \cdot C_{ntot} \cdot \Delta T_{MAX}$  and taking corrective action to reduce the power generated  $I_{RMS}^2 \cdot R_{WIRE}$ ; and continuing to check each interconnect conductor with alternating current flow until all interconnect conductors have a value for power generated  $I_{RMS}^2 \cdot R_{WIRE}$  less than the power limit  $F \cdot C_{ntot} \cdot \Delta T_{MAX}$ .

- [c14] 14. The method of claim 13, wherein the thermal conductances  $G_{thi}$  are determined from the product of the capacitances  $C_{ni}$  and a factor F and the scalar factor F is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

- [c15] 15. The method of claim 13, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T_{MAX}$ .
- [c16] 16. The method of claim 13, wherein the  $I_{RMS}$  value is determined by the expression:  
 $C_{load} * V_{dd} * frequency * Switching\ factor.$
- [c17] 17. The method of claim 13, wherein thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences  $\Delta T_{ni}$  as outputs of the circuit simulator.
- [c18] 18. The method of claim 13, wherein the capacitances  $C_{ni}$  and resistances  $R_{WIRE}$  are determined by using simulation and analysis tools that at least include capacitance/resistance extraction capabilities.
- [c19] 19. A computer-readable medium having a plurality of computer executable instructions for causing a computer to perform an electromigration check for conductors with alternating current flow adjacent to conductors with direct current flow in an integrated circuit, the computer executable instructions comprising:  
determining resistances  $R_{WIRE}$  and a capacitance ma-

trix  $C$  for the integrated circuit;  
 converting the capacitance matrix  $C$  into a thermal conductance matrix  $G$ ;  
 determining temperature differences  $\Delta T_{ni}$  between conductors from thermal conductances  $G_{thi}$  of the thermal conductance matrix  $G$ ;  
 approximating power flow  $P_n$  into conductors with direct current flow due to adjacent conductors with alternating current flow in the integrated circuit from the temperature differences  $\Delta T_{ni}$  between conductors and the thermal conductances  $G_{thi}$ ;  
 determining a power limit as a function of the maximum temperature difference  $\Delta T_{MAX}$  that ensures reliability of the integrated circuit; and  
 performing the electromigration check by limiting power generated in the conductors with alternating current flow to less than the power limit.

[c20] 20. The method of claim 19, wherein the thermal conductance matrix  $G$  is determined from the product of the capacitance matrix  $C$  and a scalar factor  $F$  and the scalar factor is given by a ratio of thermal conductivity  $\kappa$  to permittivity  $\epsilon$ .

[c21] 21. The method of claim 1, wherein the power limit is given by the product of scalar factor  $F$ , the total capacitance  $C_{ntot}$  and the maximum temperature difference  $\Delta T$

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[c22] 22. The method of claim 1, wherein the  $I_{RMS}$  value is determined by the expression:

$$C_{load} * V_{dd} * frequency * Switching\ factor.$$

[c23] The method of claim 1, wherein the thermal conductances  $G_{thi}$  are inputs for a circuit simulator that determines temperature differences between conductors  $\Delta T_{ni}$  as outputs of the circuit simulator.